

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Sun-Uk Kim et al. Art Unit : 1791
Serial No. : 10/560,023 Examiner : Erin Lynn Snelting
Filed : December 8, 2005 Conf. No. : 1005
Title : Method For Fabricating A Porous Silica Sphere

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL REPLY TO FINAL ACTION OF NOVEMBER 13, 2009

Please amend the above-identified application as follows: